

<b>Notice of References Cited</b>	Application/Control No. 10/584,095	Applicant(s)/Patent Under Reexamination SCHEUCHER, HEIMO	
	Examiner Cuong Q. Nguyen	Art Unit 2811	Page 1 of 1

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*	B	US-6,114,072	09-2000	Narimatsu, Koichiro	438/462
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**NON-PATENT DOCUMENTS**

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